IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Daniel Luch	) Examiner: M. Chapman
Application No. 09/498,102	) Art Unit: 1741
Filed: February 4, 2000	) May 18,2001
For: SUBSTRATE STRUCTURES FOR	)
INTEGRATED SERIES CONNECTED	RECEIVED  MAY 2 3 2001  TC 1700
PHOTOVOLTAIC ARRAYS AND	MAY 2 3 2001
PROCESS OF MANUFACTURE OF SUCH	TC 1700
ARRAYS	)

**CERTIFICATE OF MAIL** 

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as First Class Mail in an envelope addressed to Assistant Commissioner for Patents, Washington, C.C. 20231 on

Daniel Luch

## INFORMATION DISCLOSURE STATEMENT

**Assistant Commissioner for Patents** Washington, D.C. 20231

Sir:

This Information Disclosure Statement, Form 1449 (2 pages, 21 references) and the corresponding 21 U.S. Patent documents are hereby submitted in accordance with Applicant's continuing duty to bring any information which may be material to patentability to the Examiner's attention.

Respectfully submitted,

Daniel Luch

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## FAX TRANSMISSION

TO: Examiner Mark Chapman

FROM: Daniel Luch

RE: Application Serial No. 09/498,102

FILED: February 4, 2000

**ART UNIT: 1741** 

<u>FOR:</u> Substrate Structures For Integrated Series Connected Photovoltaic Arrays And Process Of Manufacture Of Such Arrays

**DATE:** May 21, 2001

Transmitting total of one (1) page.

MESSAGE: An IDS relating to the above-identified application was mailed (Express Mail) from Morgan Hill, CA. on May 18, 2001. It should arrive in the PTO box on May 21, 2001. Twenty-one U.S. Patents were included in this mailing as part of the IDS.

Sincerely,

Daniel Luch